

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Ronghua WEI, et.al. \$ Group Art Unit: 1775
Serial No.: 10/693,076 \$ Examiner: Michael E. Lavilla
Filed: October 24, 2003 \$ Atty. Docket No.: SwRI-2890-04
Title: Tubular Structures with Coated Interior Surfaces

MAIL STOP AMENDMENT

Commissioner for Patents
PO BOX 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In light of the recent decision in McKesson Information Solutions v. Bridge Medical, Inc., (Fed. Cir. 2006, 1517) decided on May 18, 2007 and in compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the references listed on the attached Form PTO-1449 (Modified) be considered by the Examiner and made of record.

This Supplemental Information Disclosure Statement is not to be considered as a representation that a search has been made or that no other material information as defined under 37 C.F.R. § 1.56 exists.

The commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account No. 50-0997 (SWRI-2890-04), maintained by Paula D. Morris & Associates, P.C. d/b/a The Morris Law Firm, P.C..

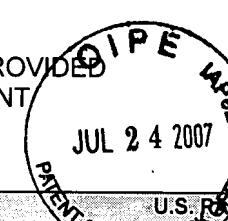
Respectfully submitted,

Paula D. Morris, Reg. No. 31,516
The Morris Law Firm, P.C.
10260 Westheimer, Suite 360
Houston, Texas 77042-3108
Telephone: (713) 334-5151
Facsimile: (713) 334-5157

FORM PTO-1449 (Modified)

LIST OF INFORMATION PROVIDED
BY APPLICANT

(Use several sheets if necessary)

ATTY. DOCKET NO.
SwRI-2890-04APPLICATION NUMBER
10/693,076APPLICANT
Ronghua WEI, et. al.FILING DATE
October 24, 2003GROUP ART UNIT
1775

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Patentee	Class	Subclass	Filing Date if Appropriate
	AA	3,952,334	04-27-1976	Bokros			
	AB	2004/0115377 A1	12-11-2003	Wei			
	AC	7,052,736	05-30-2006	Wei			
	AD	6,767,436 B2	07-2004	Wei			
	AE	6,193,852 B1	02-2001	Yumshtyk			
	AF	5,026,466 A	06-1991	Wesemeyer			
	AG	2006/0076231 A1	04-13-2006	Wei			
	AH	4,221,652	09-09-1980	Kuriyama			
	AI	5,272,735	12-21-1993	Bryan			
	AJ	4,009,090	02-22-1977	Veigel			
	AK	4,169,477	10-02-1979	Bokros			
	AL	4,444,643	04-1984	Garrett			
	AM	4,179,351	12-1979	Hawton			
	AN	5,096,562	03-1992	Boozenny			
	AO	2006/0076235 A1	04-13-2006	Wei			

REFERENCE DESIGNATION

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation Yes	No
	AP	UK 2-125-441 A	07-07-1983	United Kingdom				

OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

	AQ	USPTO, First Office Action for Application Number 10/167,189, July 16, 2003.
	AR	THE MORRIS LAW FIRM, P.C. Response to First Office Action for Application Number 10/167,189, September 29, 2003.
	AS	USPTO, First Office Action for Application Number 10/807,039, September 26, 2005.
	AT	THE MORRIS LAW FIRMS, P.C., Response to First Office Action for Application Number 10/807,039, December 21, 2005.
	AU	HOSOKAWA, et. al., Self-Sputtering Phenomena in High-Rate Coaxial Cylindrical Magnetron Sputtering, J. Vac. Sci. Technol. Vol. 14 No.1, Jan./Feb. 1977, pp 143-146.
	AV	PCT, International Search Report for PCT/US2005/24110 of 31 January 2006.
	AW	PCT, Written Opinion for PCT/US2005/24110 of 31 January 2006.
	AX	PCT, International Preliminary Report on Patentability for PCT/US2005024110 of 26 April 2007.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

1. The attached cited information should not be construed as an admission that any of the above items are prior art to the subject invention.
2. This is not a representation that a search has been made.

FORM PTO-1449 (Modified)		ATTY. DOCKET NO. SwRI-2890-04	APPLICATION NUMBER 10/693,076
LIST OF INFORMATION PROVIDED BY APPLICANT		APPLICANT Ronghua WEI et. al.	
(Use several sheets if necessary)		FILING DATE October 24, 2003	GROUP ART UNIT 1775
[OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)]			
	BA	MALIK et. al. Development of an energetic ion assisted mixing and deposition process for TiNx and diamondlike carbon films, using a co-axial geometry in plasma source ion implantation; J. Vac. Sci. Technol., Nov/Dec 1997, 2875-2879, A15, American Vacuum Society.	
	BB	ENSINGER, An Apparatus for sputter coating the inner walls of tubes, Rev. Sci. Instrum, January 1996, 318-321, 67(1), American Institute of Physics.	
	BC	USPTO, First Office Action for Application Number 10/963,341, July, 21, 2006	
	BC	THE MORRIS LAW FIRM, P.C. Response to First Office Action for Application Number 10/963,341, September 15, 2006.	
	BE	USPTO, Second Office Action for Application Number 10/963,341, November 20, 2006.	
	BF	THE MORRIS LAW FIRM, P.C. Response to Second Office Action for Application Number 10/963,341, January 19, 2007.	
	BG	English Translation of Japanese Publication No. JP 4-107268 also referred to as Japanese Patent Application No. H02-224696, Published April 8, 1992, Entitled "Processing Device of Mixed Gas," Inventor: Naoyoshi Fujiwara, Application: TOSHIBA Corporation, pp 381-385.	
	BH	USPTO, First Office Action after RCE for Application Number 10/963,341, February 15, 2007.	
	BI	THE MORRIS LAW FIRM, P.C. Response to First Office Action after RCE for Application Number 10/963,341, April 18, 2007.	
	BJ	USPTO, Second Office Action after RCE for Application Number 10/963,341, July 6, 2007.	
	BK	THE MORRIS LAW FIRM, P.C. Article 19 Amendments for PCT/US2005/24110, March 24, 2006	
	BL	WIPO, WO 2006/044002 A2 International Application for PCT/US Number 2005/024110, April 27, 2006.	
	BM	PCT, International Search Report for PCT/US05/24119, July 11, 2006.	
	BN	PCT, Written Opinion for PCT/US05/24119, July 11, 2006.	
	BO	PCT, International Preliminary Report on Patentability for Application PCT/US05/24119, April 26, 2007	
	BP		
	BQ		
	BR		
	BS		
	BT		
EXAMINER		DATE CONSIDERED	

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

1. The attached cited information should not be construed as an admission that any of the above items are prior art to the subject invention.
2. This is not a representation that a search has been made.